

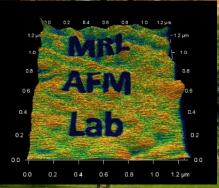
Atomic Force Microscopy

Kathy Walsh

Senior Research Scientist Scanning Probe Microscopy

Materials Research Laboratory Central Research Facilities

Physics 403 3/26/24



Illinois Materials Research Lab Central Research Facilities

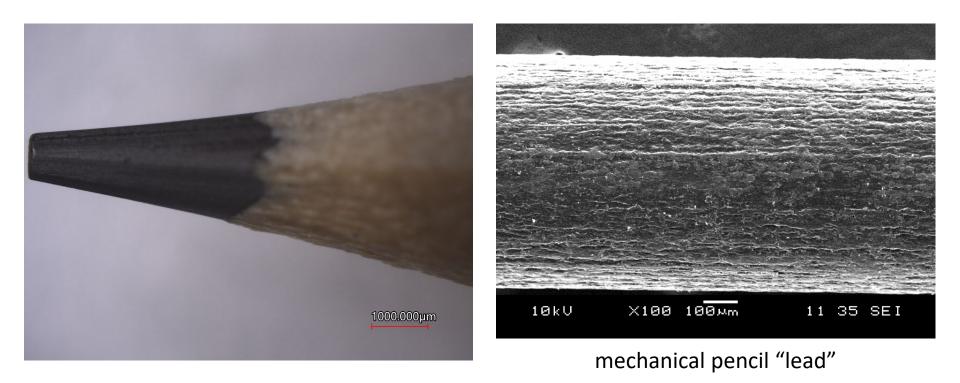
- User facility—anyone can be trained
 - UIUC and non-UIUC researchers welcome
 - Undergraduate researchers welcome
 - Staff collaboration or analysis available
- mrl.illinois.edu/facilities
- mrl-facilities@illinois.edu



Looking at Surfaces

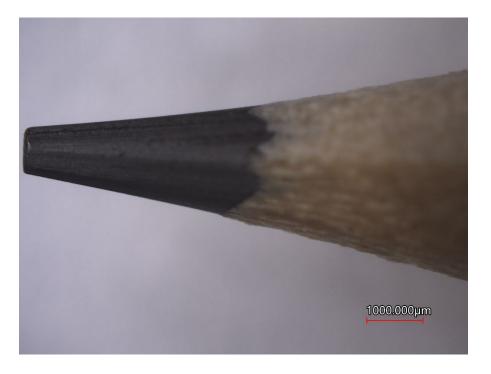
Optical Microscopy

Scanning Electron Microscopy

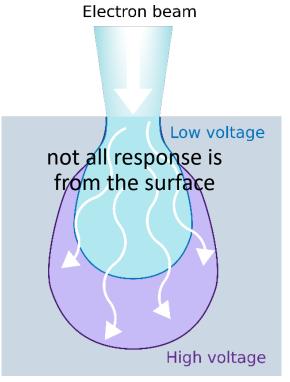


Looking at Surfaces

Optical Microscopy



Scanning Electron Microscopy

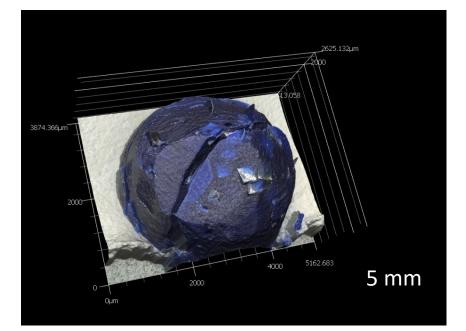


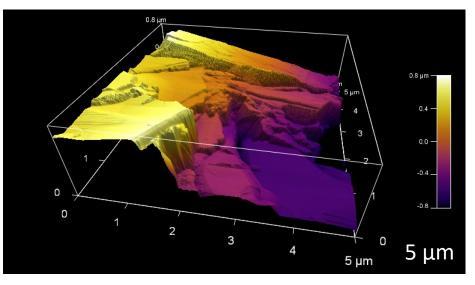
Adapted from https://myscope.training/#/SEMlevel_2_13 (CC BY-SA 4.0)

Surface XYZ Coordinates Needed

3D Optical Profilometry

Atomic Force Microscopy



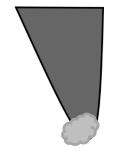


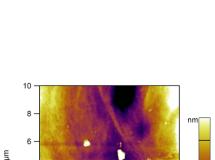
pencil "lead"

blue glitter crayon tip

Topics for Today

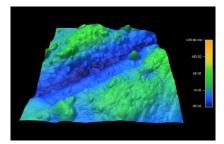
- How AFM works
- Featured applications
 - Topography
 - Profiles, step height
 - Roughness
 - Phase
 - Conductive AFM
- Issues and artifacts
- Image processing

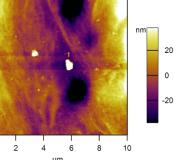


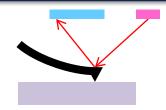


2

0+

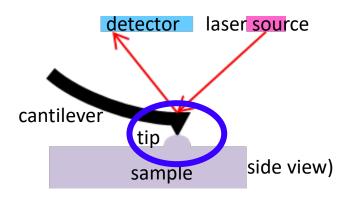


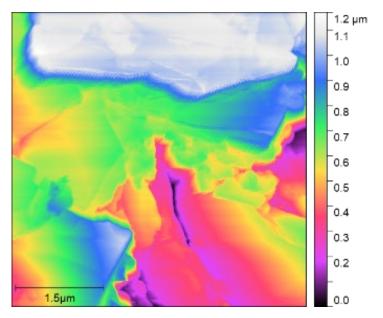




What's an Atomic Force Microscope?

"Atomic Force" Microscopy—forces between atoms in the tip and atoms in the sample





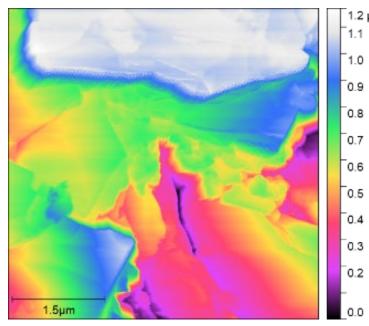
false-color surface topographs

What's an Atomic Force Microscope?

- "Atomic Force"—interactions between tip and sample
 - Not actual atomic resolution (usually)
 - Nanoscale lateral resolution (depends on tip)
 - Sub-angstrom vertical resolution

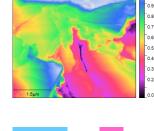


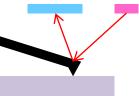
"Microscope"—surface topograph (false color)

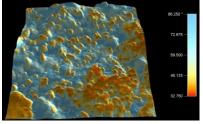


What's an Atomic Force Microscope?

- "Atomic Force"—interactions between tip and sample
 - Sub-angstrom vertical resolution
 - Not actual atomic resolution (usually)
 - Nanoscale lateral resolution (depends on tip)
- "Microscope"—surface topograph (false color)
- Tip at the end of a cantilever
- Raster tip over surface to build up an image
- Also sensitive to sample stiffness, adhesion, other properties depending on tip choices



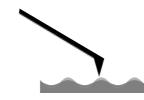




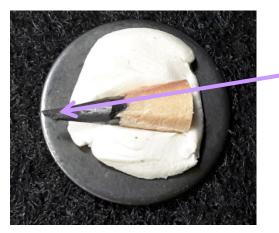
Typical AFM Scales

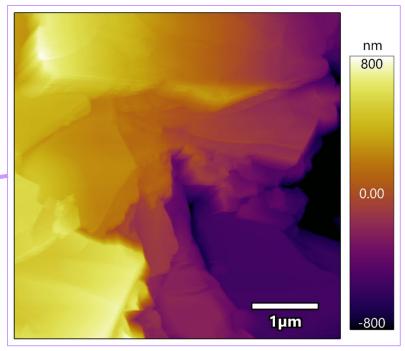
(only what's pretty common, not all of what's possible)

- Image sizes -- few to tens of μm²
- Feature peak-to-valley -- Å to μm

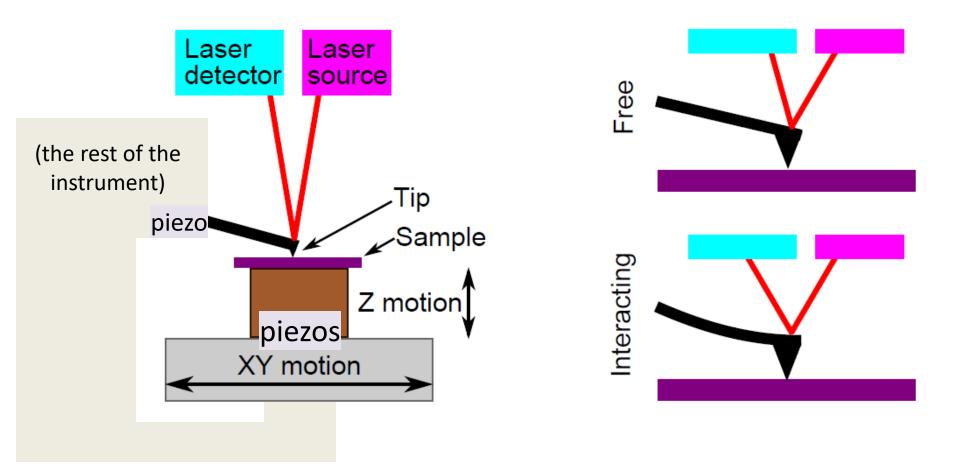


- Sample sizes -- mm to cm
- AFM measures surfaces





AFM Schematic

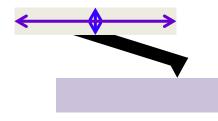




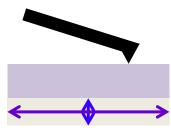
Scanners

scanning probe microscopy

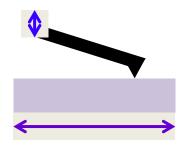
tip scanning



sample scanning



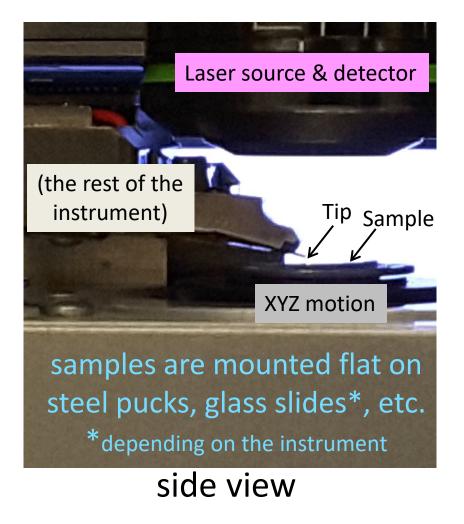
decoupled scanning



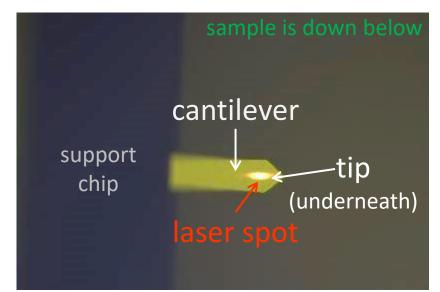
tapping is done close to or at the cantilever (tapping mode will be discussed later)



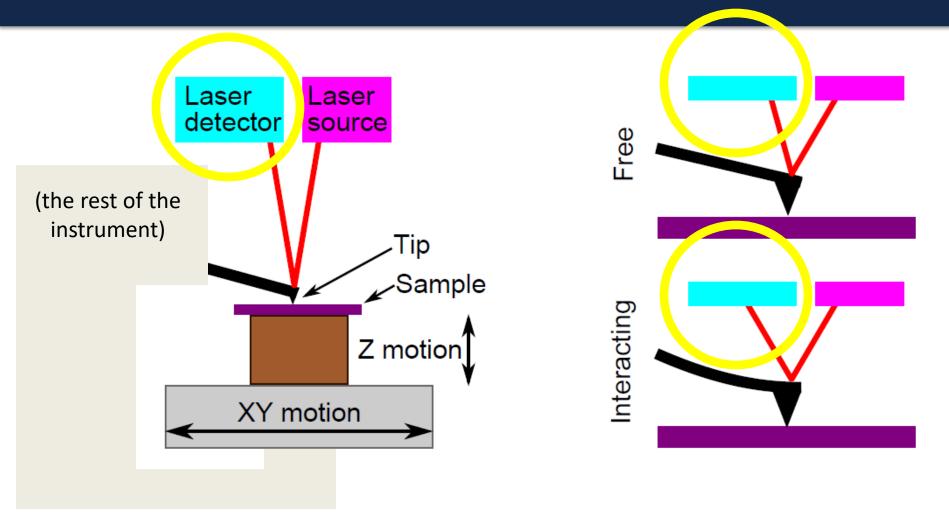
AFM Instrument



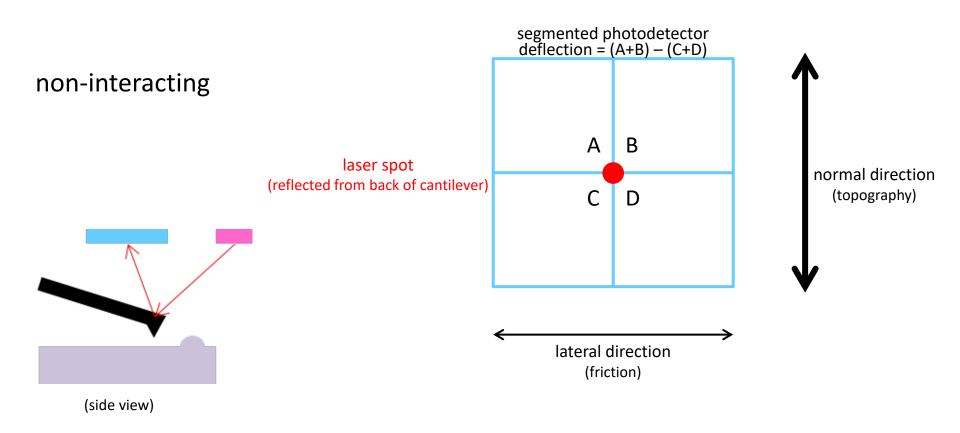
top view



AFM Schematic



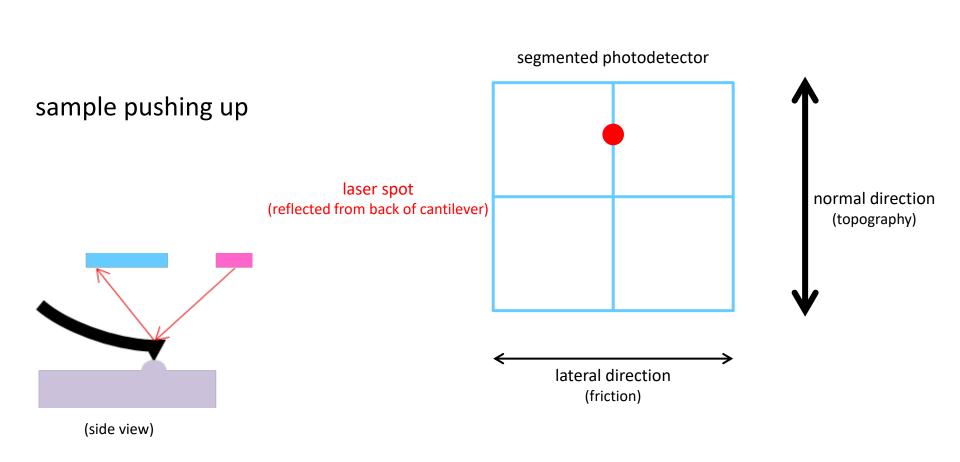
Laser Detection



(exaggerated schematic)

Ι

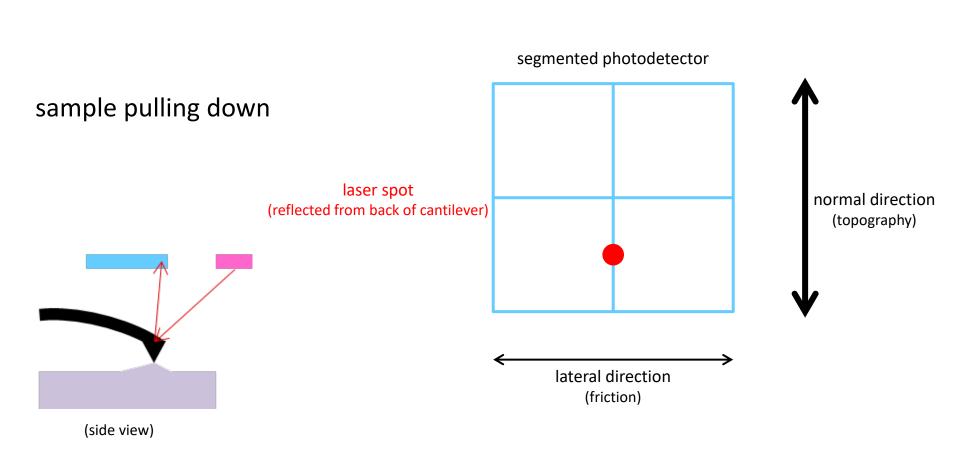
Laser Detection



(exaggerated schematic)

Ι

Laser Detection

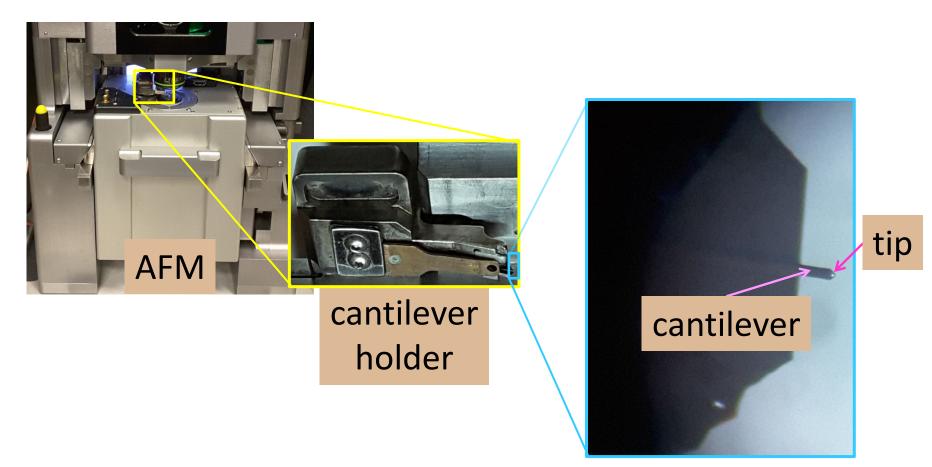


(exaggerated schematic)

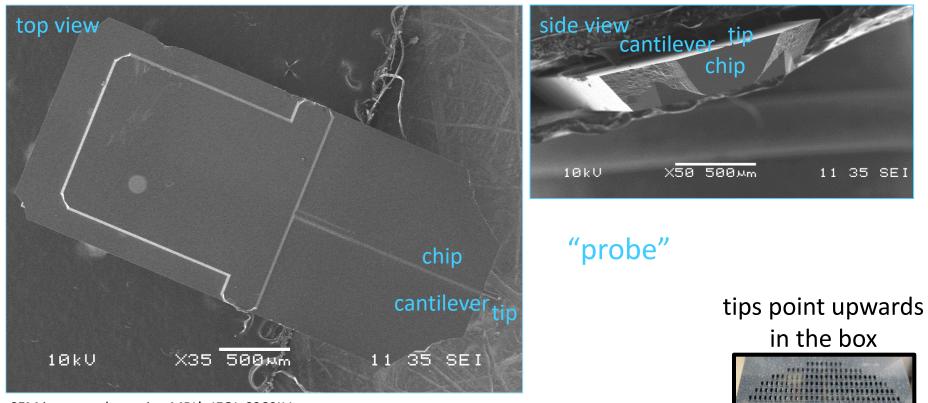


AFM Tips

scanning probe microscopy

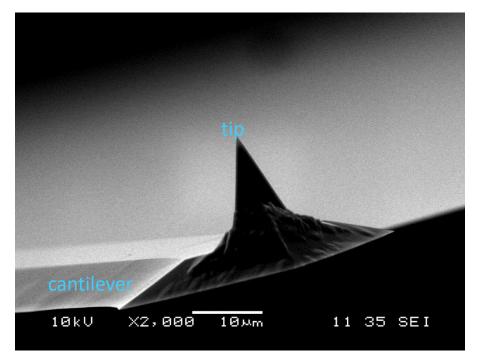


Tip Terminology

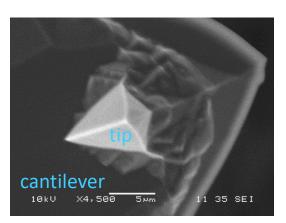


SEM images taken using MRL's JEOL 6060LV

Typical Tip



SEM images taken using MRL's JEOL 6060LV



common tip for imaging:

- tip radius of curvature < 10 nm
- silicon tip
- cantilever width 30 μ m
- cantilever length 125 μm
- cantilever thickness 4 μm



Tip Types

- Typical tapping tip cost ~\$21
- Specialized tips cost more
 - Coatings (electrical, magnetic) usually a couple more dollars per tip
 - Ultrasharp tips ~\$80-200
 - Coaxial microwave waveguide tips ~\$150
 - Colloidal probes, coated tips, made-to-order probes available



"How long does a tip last?"

- Tips are consumables
 - Contamination from samples
 - Wear from samples
 - Dropping them



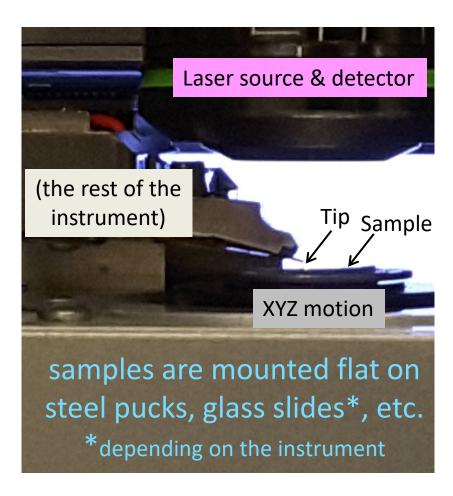
- When your tip goes bad, just throw it out!
- Generally come in 10-packs

- 50-packs if you scan a whole lot



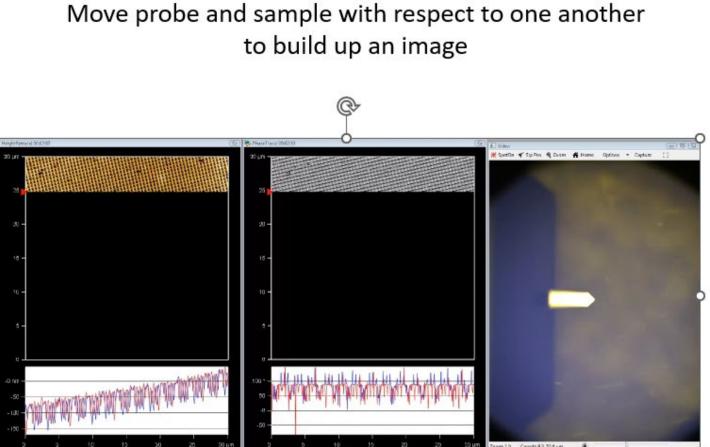
The Process

- Mount tip
- Mount sample
- Scan
- Process image
- Extract numbers (application-dependent)

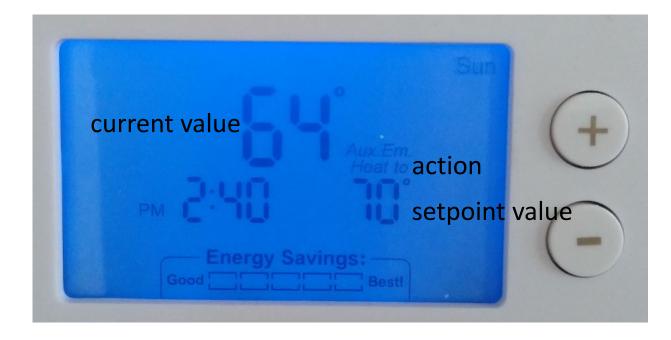


Raster Scanning



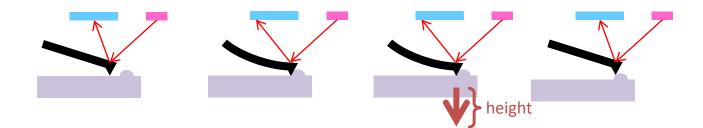






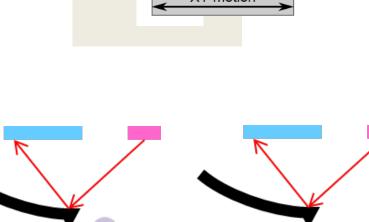
Feedback

- z piezo extension adjusted to keep feedback signal equal to setpoint
 - too much force—move away
 - too little force—move closer
 - deflection for contact mode, usually amplitude for tapping mode
- distance extended or retracted describes the height of the feature



Contact Mode Imaging

- Drag tip along surface like a stylus profilometer (or like a record player)
- Adjust tip—sample separation to keep cantilever deflection constant
 - Traces sample topography
 - Some AFMs move tip; some move sample

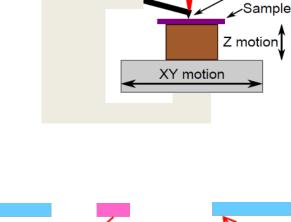


aser

detector

Laser

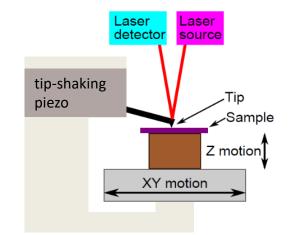
source



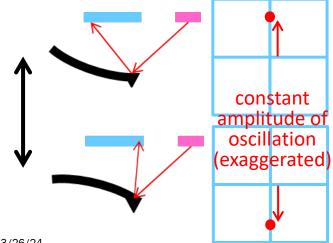
sample

Tapping Mode Imaging

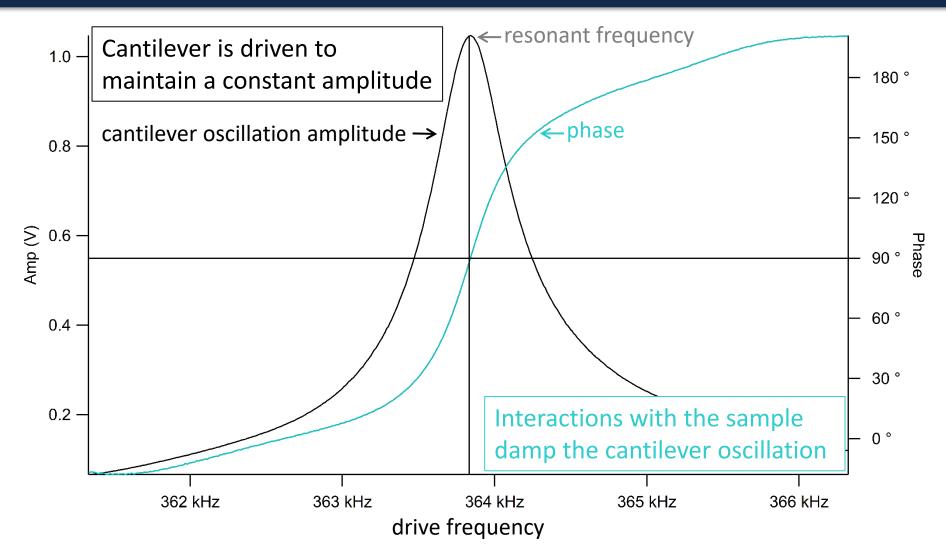
- Standard mode for AFM topography
- Intermittent contact, tapping, AC, amplitude modulation mode
- Not constantly in contact with the surface
- Driven, oscillating cantilever
- Tip—sample interactions affect oscillation







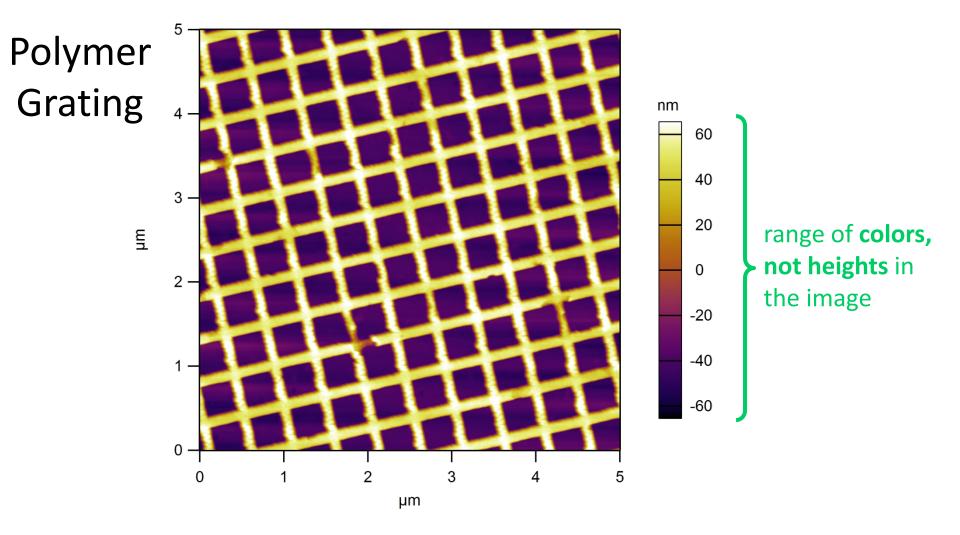
Tuning the Cantilever



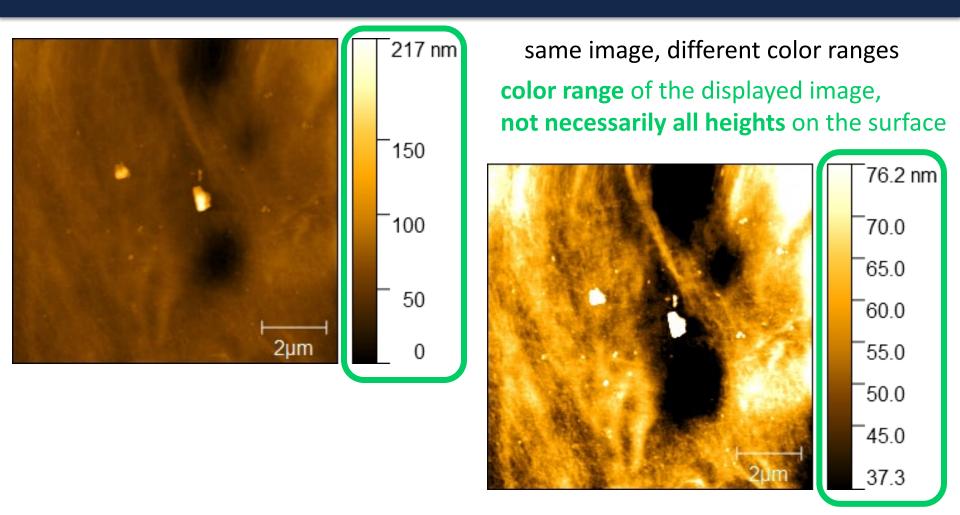
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Application: Imaging

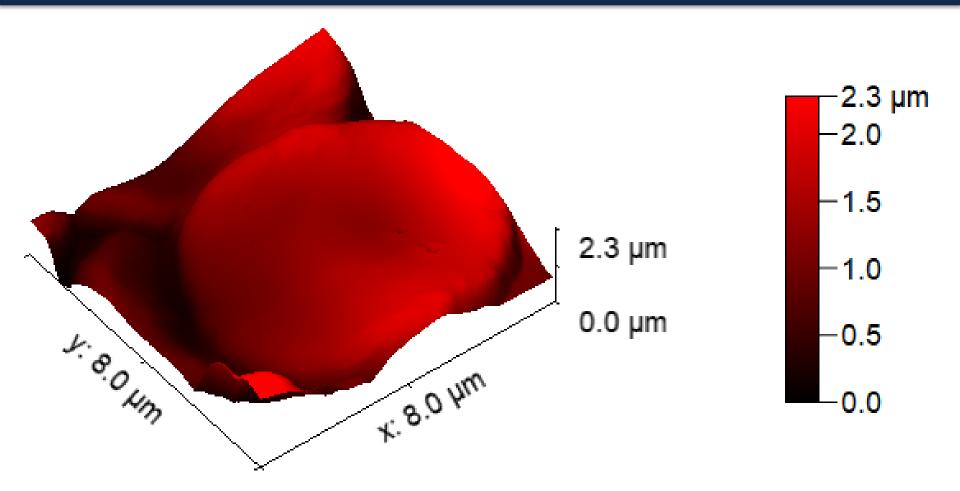


Reading the Colorscale



BOPP/PE polymer blend (toothbrush packaging), 10µm x 10µm AFM topograph

Interpreting 3D Images

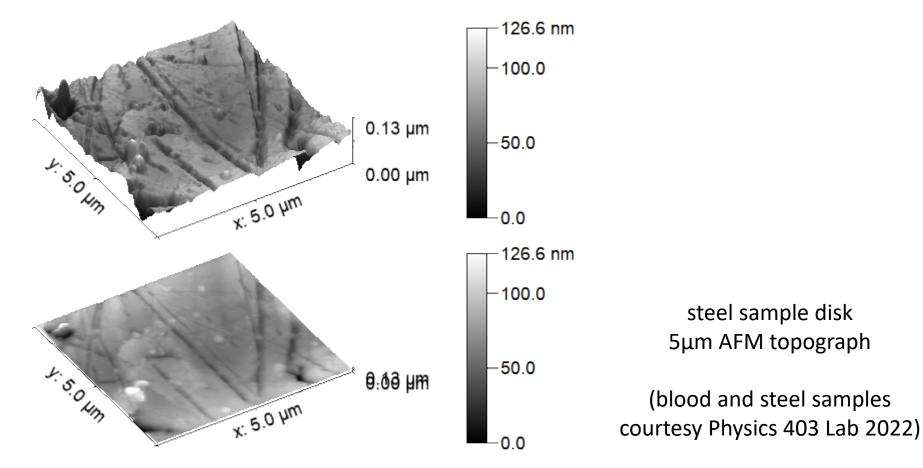


blood cells, 8µm x 8µm AFM topograph

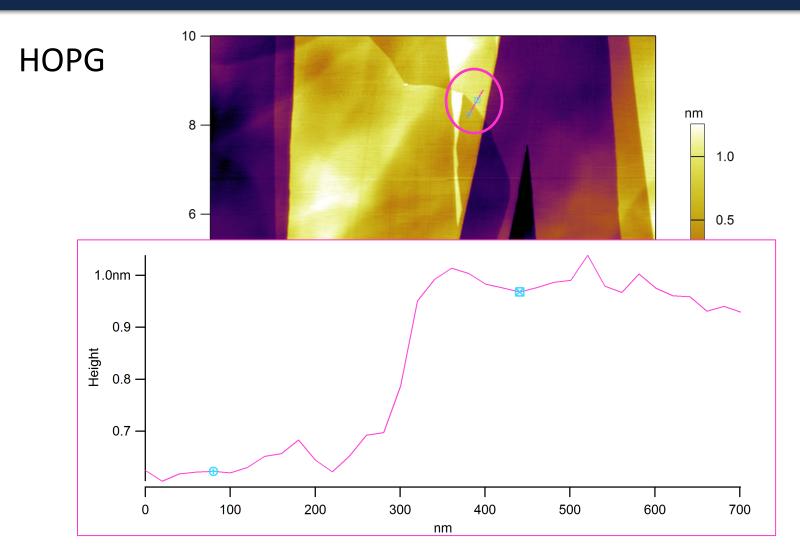
Interpreting 3D Images

not necessarily 1:1:1 z:x:y

z often exaggerated compared to xy to convey texture information



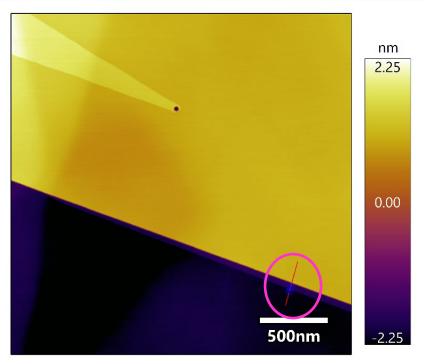
Application: Step Heights

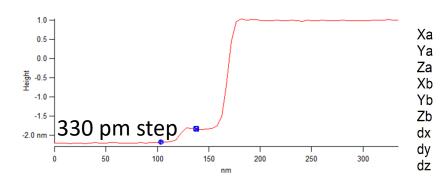


Application: Step Heights

HOPG

(highly oriented pyrolytic graphite)



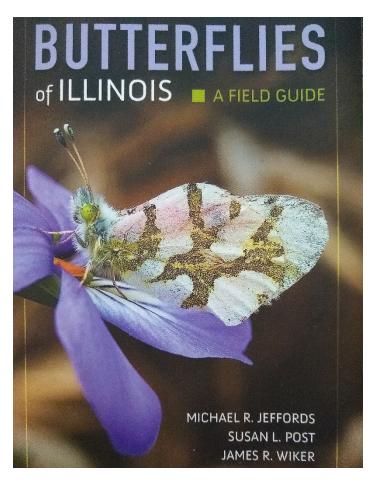


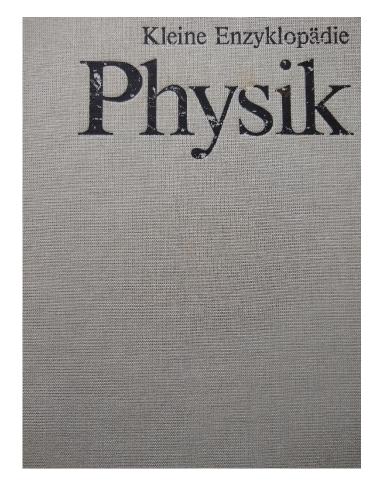
HOPG_0006HeightTraceMod0

2.04 μm 458.97 nm -2.18 nm 2.05 μm 492.15 nm -1.85 nm 9.31 nm 33.18 nm 332.26 pm

Step Heights and Thicknesses

Which book is thicker?

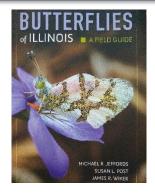


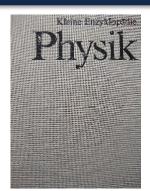


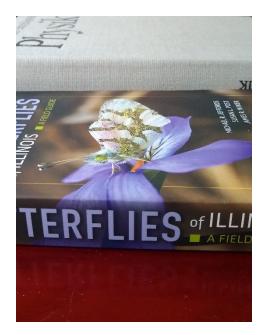
Step Height: Relative Height

 Film thickness is measured by step height

- Measure a height difference
 - Leave some bare substrate (patches are OK)
 - Scratch down to the substrate
 - Multilayer material—exposed underlayer







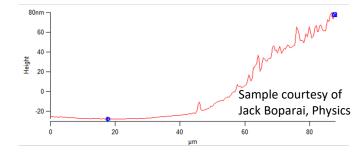
Step Height/Film Thickness: Complementary Techniques

If your step's too broad for the AFM (edge width >~80um), try...

- Stylus profilometry
- 3D optical profilometry
- X-ray Reflectivity (XRR)
- Rutherford Backscattering Spectrometry (RBS)

Continuous film (no steps)
 May need to know density

Need a height difference (step) like AFM

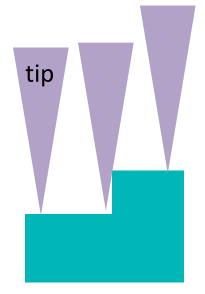


Width Measurements

Beware of tip shape convolution

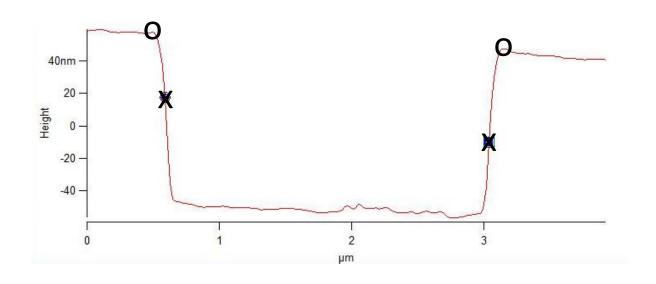
- As depth increases, tips get broader
- Steep drop-offs look less sharp
- High aspect ratio tips are available

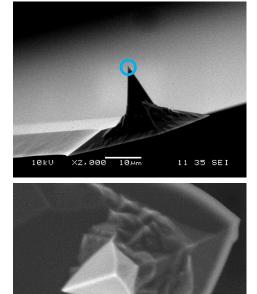




Width Measurements

- As depth increases, tips get broader
- Steep drop-offs look less sharp
- High aspect ratio tips are available





10kL

Application: Roughness

- "The roughness" depends on the scale
- Choose measurement technique to match the feature scale of interest
 - AFM (nanoscale)
 - Stylus profilometry
 - 3D optical profilometry

What is the roughness of this landscape?

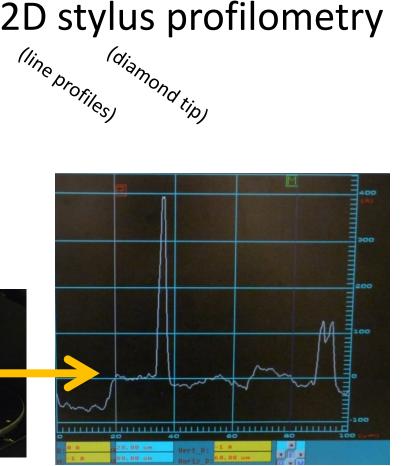


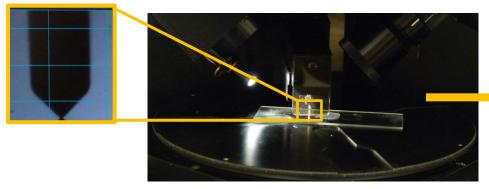
Michael Jeffords and Susan Post, University of Illinois Prairie Research Institute https://photojournalingm-s.smugmug.com/Colorado-and-Kansas/i-3tJ3DZk/A

Complementary: Stylus Profilometry



2D stylus profilometry



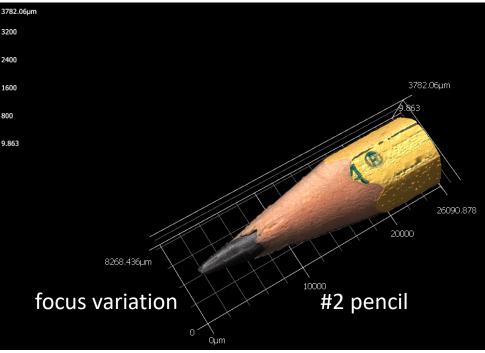


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Complementary: Optical Profilometry

go.illinois.edu/MRL3DOpticalProfilometry







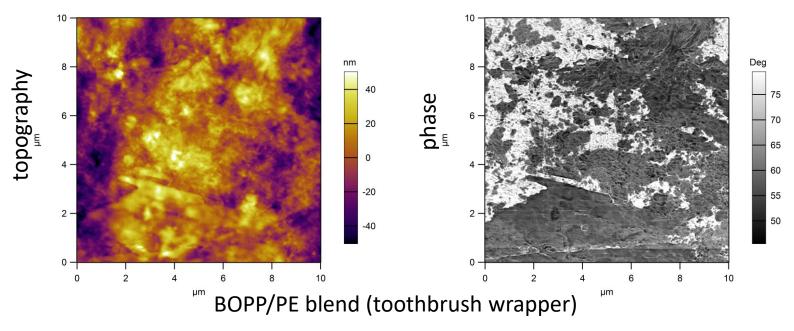
Qualitative Comparison

	AFM	2D Stylus Profilometry	3D Optical Profilometry
Vertical resolution	outstanding	ОК	ОК
Field of view	small	large	large
Data type	image	line	image
Max sample size	depends on instrument (~cm to large)	large	large
Max feature height	few µm	mm	mm
Force on sample	light	moderate	none
Speed	moderate	really fast	fast

Mechanical Characterization

Visual impact of mechanical differences

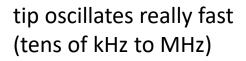
- Phase (tapping mode)
- Force modulation, AM-FM, contact resonance, etc.
- Maps of quantitative measurement results (force mapping)

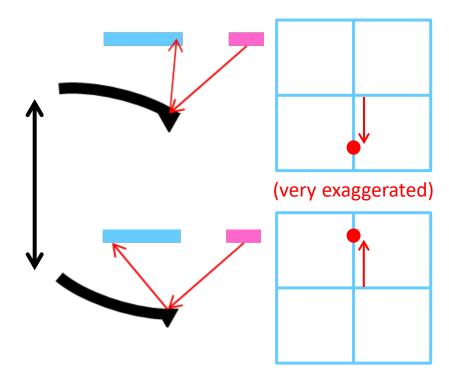


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Tapping Mode Imaging: Phase

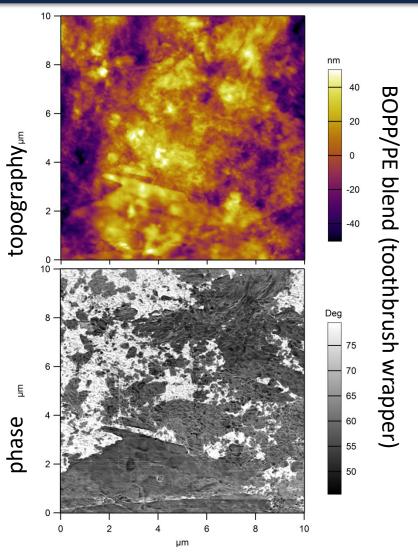
- Oscillating cantilever
- Tip—surface interactions affect oscillation
 - Cantilever driven sinusoidally to keep a constant amplitude
 - Dissipative interactions cause a phase lag (delay)
 - Viscous areas
 - Sticky areas



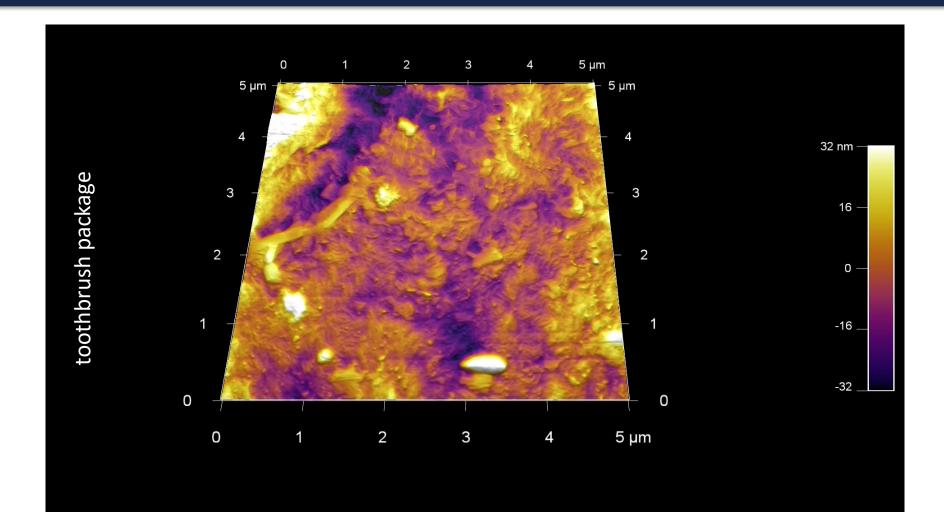


Phase (Qualitative)

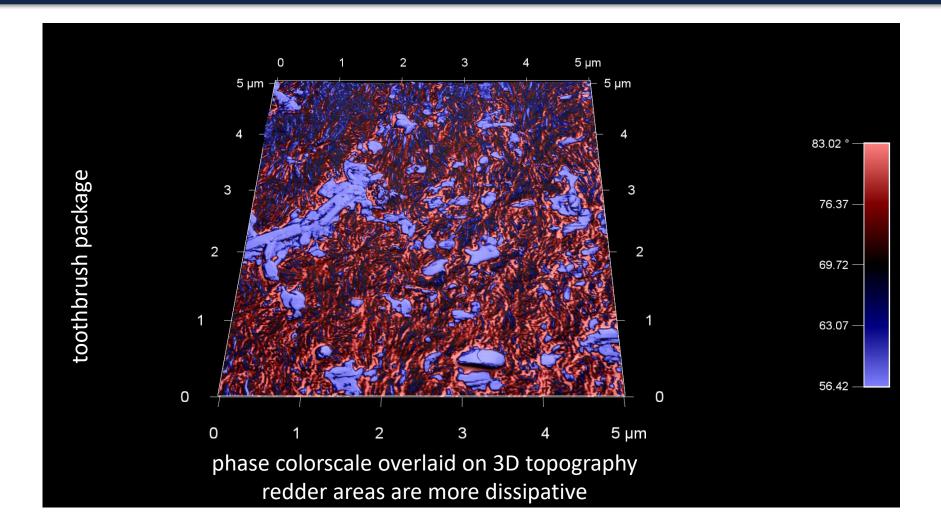
- Tapping mode imaging
- Contrast in phase image shows differences in mechanical properties
 - Qualitative, not quantitative
 - Great for mixtures
 - Great for soft materials deposited on hard surfaces



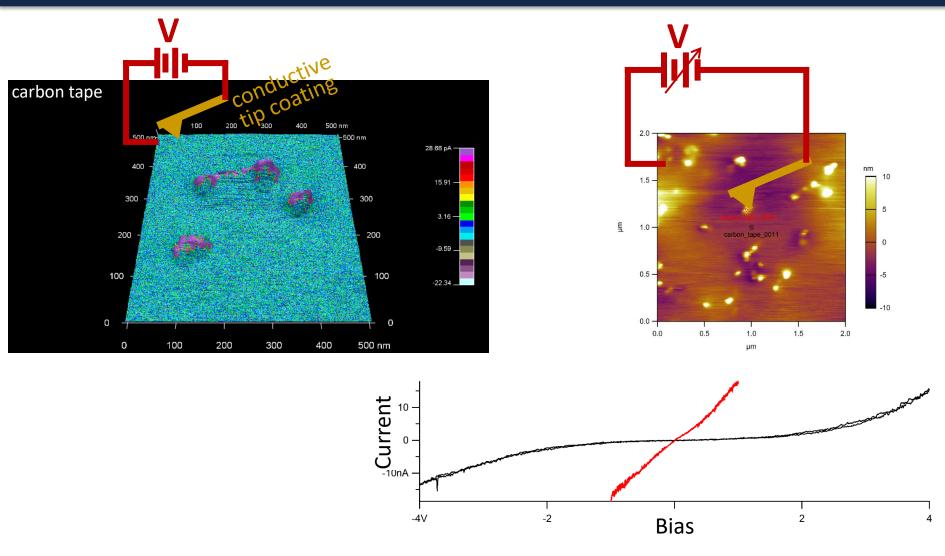
Topography



Topography with Colors from Phase



Common Application: Conductive AFM



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Artifacts and Image Processing

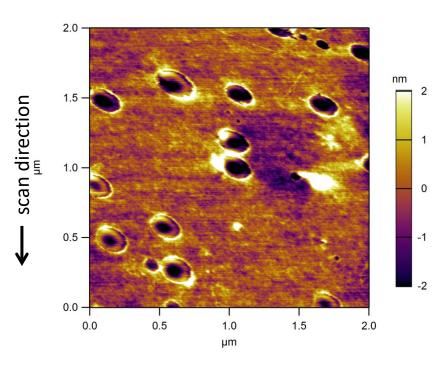
 Recognize what is (or is not) informative about the sample

• Images may not always exactly represent the sample: sample drift, tip condition/geometry

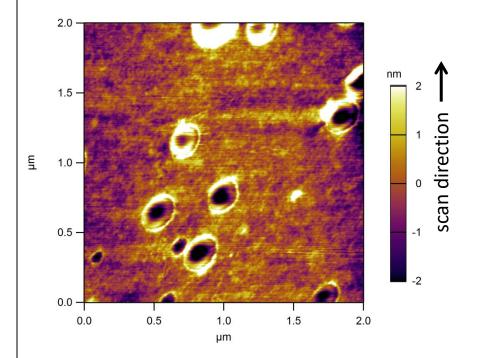
Display data in an informative way
 – Correct for sample tilt, etc.

Sample Drift

Scanning downwards...



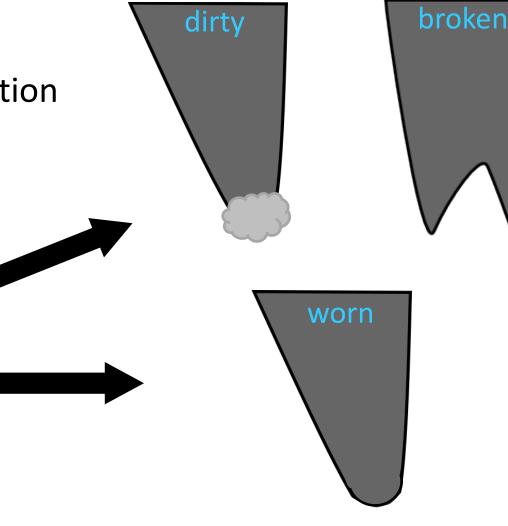
... then scanning upwards



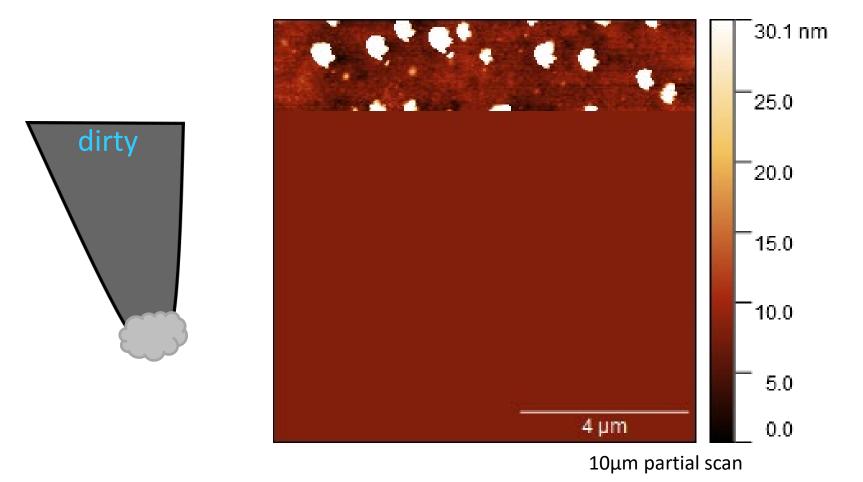
chewing gum

Tip Artifacts

- Multiple tip
 - Tip contamination
 - Tip breaking
- Tip wear

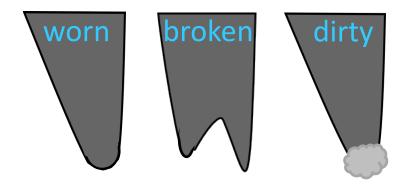


Contaminated Tip



Tip Artifacts

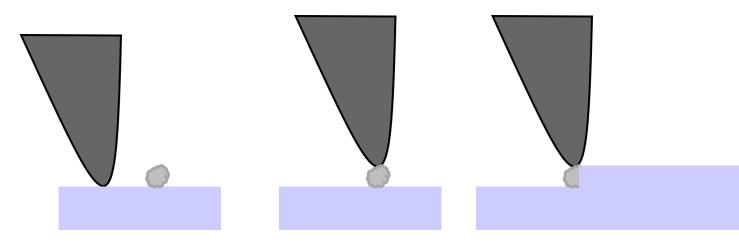
- Tip shape change
 - Multiple tip
 - Tip contamination
 - Tip breaking
 - Tip wear



- Tip height change
 - Tip contamination
 - Tip wear

Line-by-Line Subtraction

- Difference from line to line
- Tip condition changes, curvature
- Polynomial subtraction



Ι

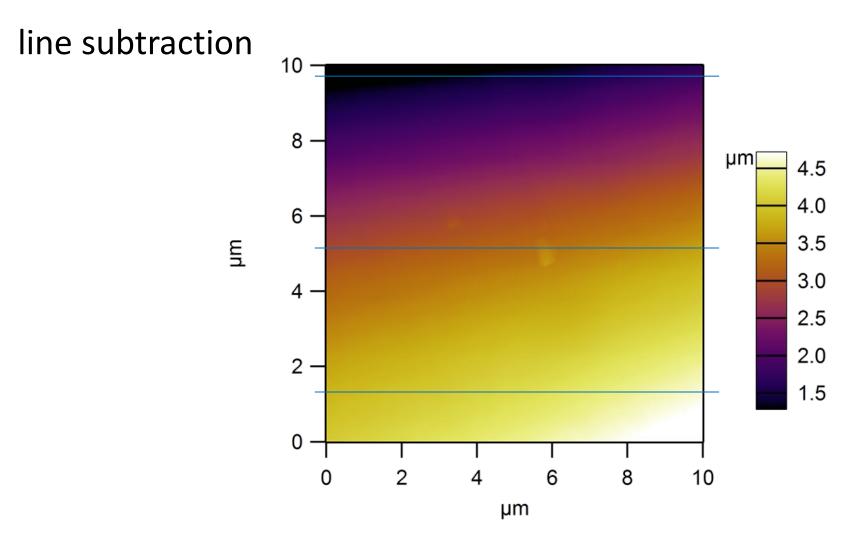
Image Processing

raw image 10 8 μm 4.5 4.0 6 -3.5 μп 3.0 4 2.5 2.0 2 1.5 0 2 6 8 10 0 4 μm

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Ι

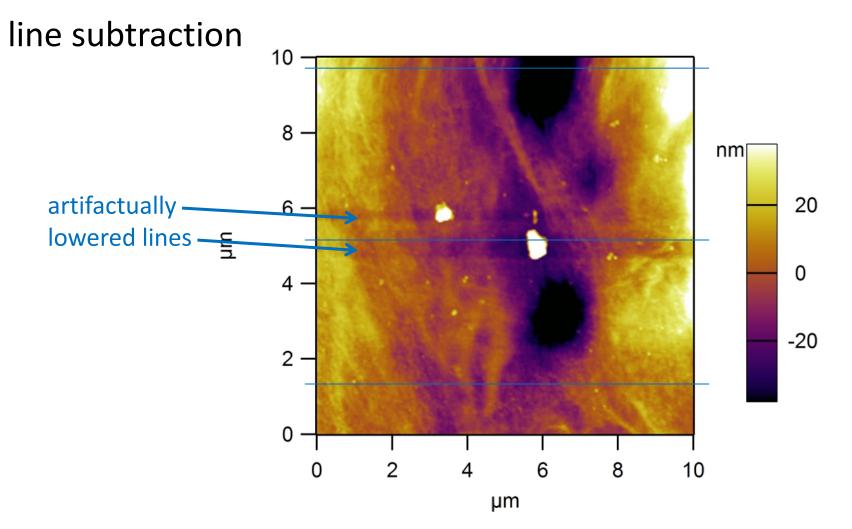
Image Processing



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Ι

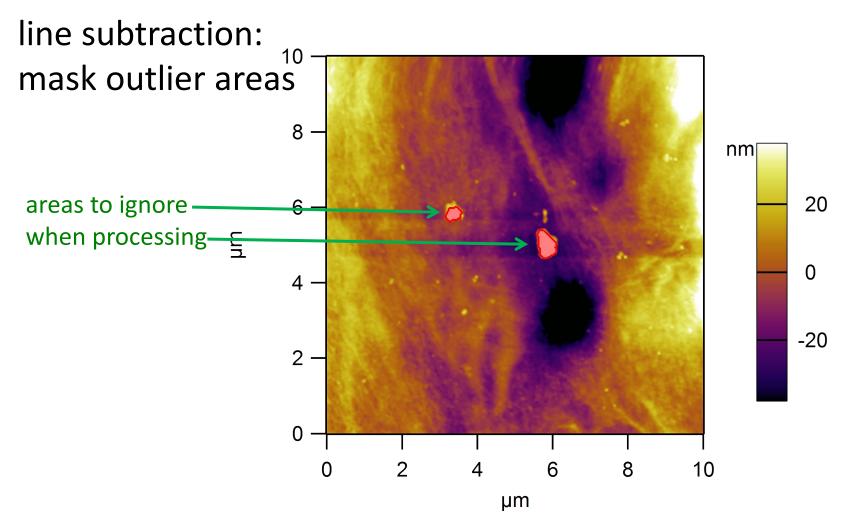
Image Processing



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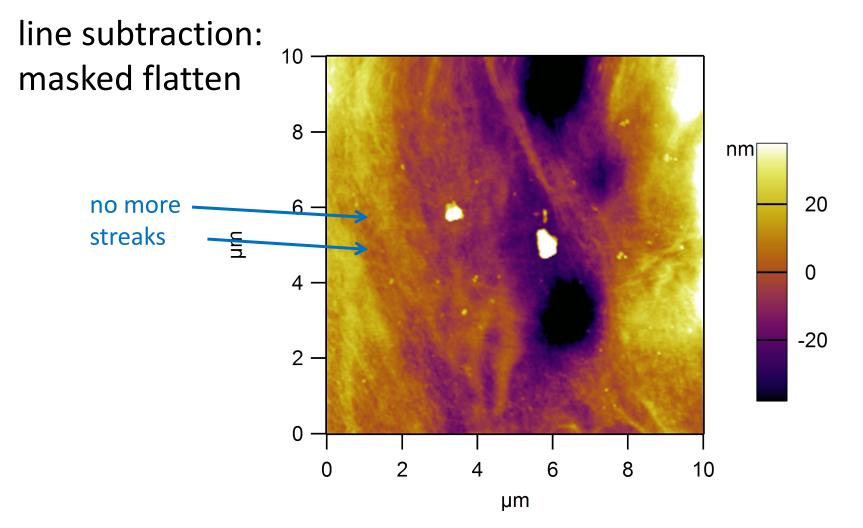
Image Processing



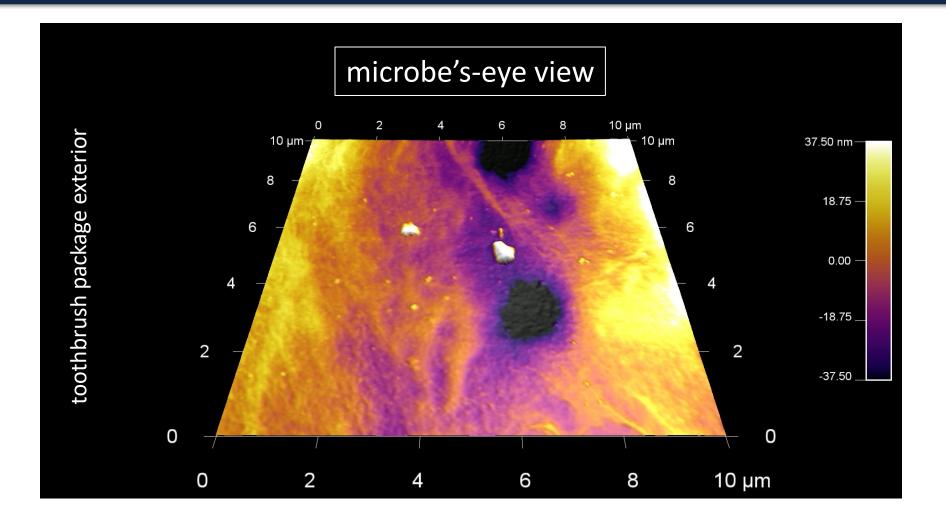
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Image Processing



3D Display

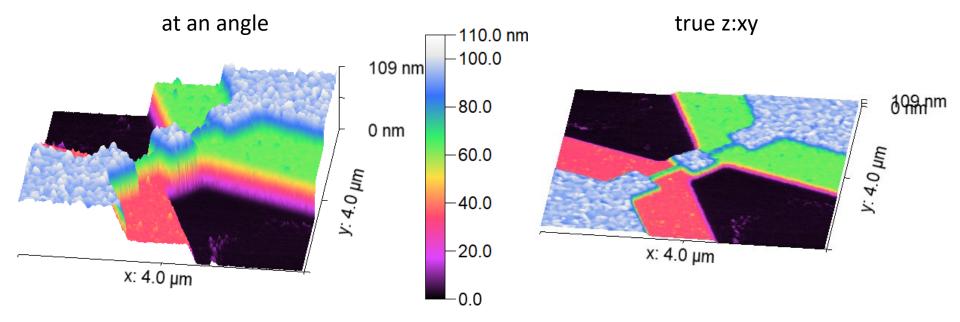


3D Display

face on side view 110.0 nm -110.0 nm -100.0 -100.0 -80.0 ~100 nm_{109 nm}^{-80.0} y: 4.0 µm -60.0 60.0 0 n<mark>m</mark>_40.0 x: 4.0 µm v: 4.0 un -40.0 ~4000 nm -20.0 -20.0 -0.0 -0.0 x: 4.0 µm 009mm

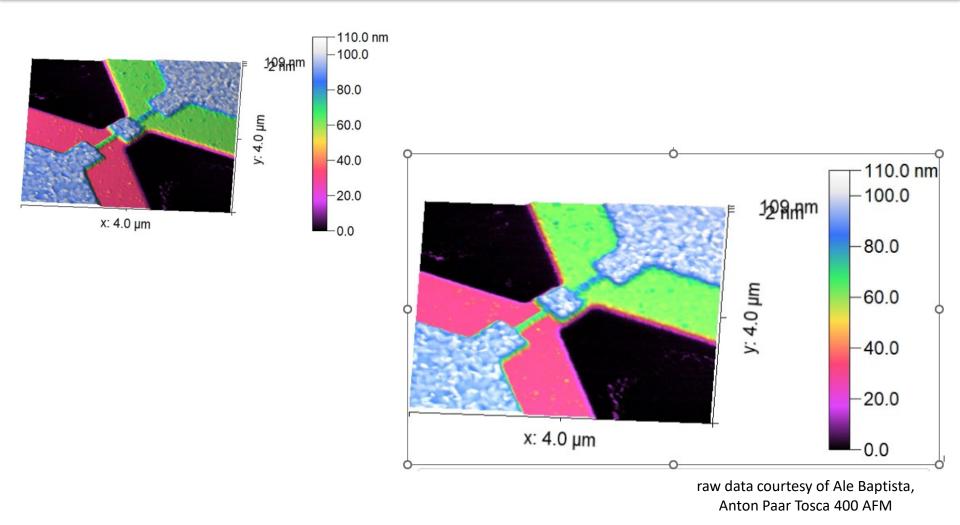
> raw data courtesy of Ale Baptista, Anton Paar Tosca 400 AFM

3D Display—z:xy



raw data courtesy of Ale Baptista, Anton Paar Tosca 400 AFM

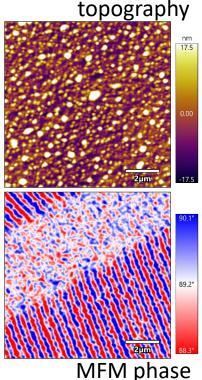
3D Display—Lighting Angle



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Many Other Applications

- Nanolithography/nanomanipulation
- LFM (friction, lateral force microscopy)
- EFM (electrostatic force microscopy)
- KPFM (SKPM, Kelvin probe)
- MFM (magnetic force microscopy)
- PFM (piezoresponse force microscopy)



 ... and these generally don't need extra gear (except different tips)

Attachments on the MRL AFMs

- ORCA Conductive AFM
- Scanning Microwave Impedance Microscopy (sMIM)
- Environmental Controller
- 💵 BioHeater
- PolyHeater (up to 300°C)
- 🂵 Petri Dish Heater
- MFP-3D Leg Extenders
- blueDrive Photothermal Excitation
- Fast Force Mapping
- Dual-Gain ORCA Conductive AFM
- Piezoresponse Force Microscopy (HV-PFM)
- Contact Resonance Viscoelastic Mapping Mode
- AM-FM Viscoelastic Mapping Mode
- Scanning Tunneling Microscopy (STM)
- Air Temperature Controller (ATC)
- Droplet Cantilever Holder Kit









MRL AFMs—B12 MRL

Asylum Research MFP-3D-SA (2 of these) 15μm z range, 90μm x 90μm scan size



0026 Supercon: Asylum Research MFP-3D-Bio on an inverted optical fluorescence microscope

Asylum Research Cypher 5μm z range, 30μm x 30μm scan size





Related Instruments at MRL

PS-b-PMMA0004 PIFMFwd (at 1733 cm^-1) illuminated at 1733 cm⁻¹

176 ul

Vista One

Highly localized chemical information

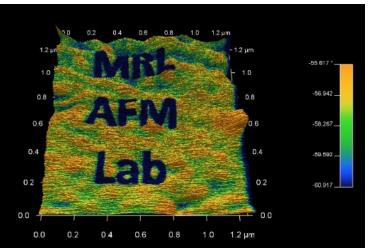
- Molecular Vista PiFM
 Photo-induced force microscopy and spectroscopy
- Horiba TERS/TEPL
 - Tip-enhanced Raman spectroscopy
- Neaspec Nano-IR
 - AFM + infrared

Profilometry

- Dektak stylus profilometer
- Keyence 3D optical profiler

Keep Learning

- MRL Webinar Series
 - go.illinois.edu/MRLYouTubeChannel
 - Basics of Atomic Force Microscopy (Kathy Walsh)
 - The Versatility of Nanomechanics with AFM (Jessica Spear)
 - 3D Optical Profilometry (Julio Soares and Kathy Walsh)
- Kathy Walsh, kawalsh@illinois.edu



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